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Vantage  
OFFICE  
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A circular black ink stamp from the Office of Intellectual Property (OIP). The text "OIP" is at the top, "JC89" is at the top right, "MAR 23 2000" is in the center, and "PATENT &amp; TRADEMARK OFFICE" is at the bottom.

Group Art Unit: 2815

Examiner: M. Warren

For: **SEMICONDUCTOR DEVICE INCLUDING CONTACT HOLES BETWEEN  
ADJACENT CONDUCTOR PATTERNS AND METHOD FOR FABRICATING  
THE SAME (AS AMENDED)**

Assistant Commissioner of Patents  
Washington, D.C. 20231

March 23, 2000

Sir:

In response to the Office Action dated November 23, 1999, please amend the above-identified application as follows:

Please amend claim 1, as follows:

Claim 1, line 9, change “contract” to --contact--.

**Please add new claims 35 and 36, as follows:**

435. A semiconductor device comprising:

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03 FC:102	78.00 00